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Docket No.: 60188-407



EFW
AF
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
ISHIBASHI, AKIHIKO, et al.	:	Confirmation Number: 6705
Serial No.: 09/692,211	:	Group Art Unit: 2812
Filed: October 20, 2000	:	Examiner: Savitri MULPURI
For: METHOD OF FABRICATING NITRIDE SEMICONDUCTOR DEVICE	:	

RESPONSE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 22, 2004, having a three-month shorten statutory period for response set to expire on October 22, 2004, reconsideration of the above-identified application is respectfully requested in view of the following comments and remarks.